



Attorney Docket No. 81784.0291  
Express Mail Certificate EV 325 214 787 US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Hidenori OGATA et al.

Serial No: Not Assigned [parent 09/291,538]

Confirmation No. 2245

Filed: November 14, 2003

For: LASER ANNEAL METHOD OF A  
SEMICONDUCTOR LAYER

Art Unit: Not Assigned

Examiner: Not Assigned

**PETITION FOR EXTENSION OF TIME**

Mail Stop Patent Application  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a one-month extension of time extending to December 8, 2003, the period for response to the Communication dated October 8, 2003. A check for \$110 is enclosed. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

11/20/2003 SDIRETRI 00000045 09291538

01 FC:1231

110.00 DP

Date: November 14, 2003

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By:

*John P. Scherlach*  
John P. Scherlach  
Registration No. 23,009  
Attorney for Applicant(s)

500 South Grand Avenue, Suite 1900  
Los Angeles, California 90071  
Phone: 213-337-6700  
Fax: 213-337-6701